



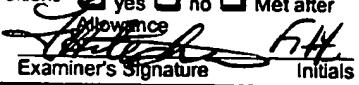
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SERIAL NUMBER 10/521,035	FILING OR 371(c) DATE 08/02/2005 RULE	CLASS 117	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. JG-SU-5207PCT/US 500577.2	
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** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08577 07/07/2003					
** FOREIGN APPLICATIONS ***** JAPAN 2002-197140 07/05/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after time Verified and Acknowledged  Examiner's Signature 		STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 6	INDEPENDENT CLAIMS 3
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TITLE Method of producing silicon monocrystal					
FILING FEE RECEIVED 1390	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			